organic compounds

Acta Crystallographica Section E **Structure Reports** Online

ISSN 1600-5368

1,4-Bis(dimethylsilyl)-2,5-diphenylbenzene

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Received 23 February 2010; accepted 23 March 2010

Key indicators: single-crystal X-ray study; T = 173 K; mean σ (C–C) = 0.003 Å; R factor = 0.055; wR factor = 0.118; data-to-parameter ratio = 20.0.

The molecule of the title compound, C₂₂H₂₆Si₂, is centrosymmetric. The dihedral angle between the central benzene ring and its phenyl substituents is $67.7 (2)^\circ$. The crystal packing is stabilized by van der Waals forces.

Related literature

For investigations on the effect of silvl substituents on the photophysics of *p*-terphenyls, see: Feng et al. (2007).



Experimental

Crystal data

C II C	IZ 1050 (4 (7) Å3
$C_{22}H_{26}S_{12}$	$V = 1958.64 (7) A^{-1}$
$M_r = 346.61$	Z = 4
Monoclinic, $C2/c$	Mo $K\alpha$ radiation
a = 14.8966 (3) Å	$\mu = 0.18 \text{ mm}^{-1}$
b = 6.0132 (1) Å	T = 173 K
c = 26.1211 (6) Å	$0.56 \times 0.39 \times 0.11 \text{ mm}$
$\beta = 123.166 \ (1)^{\circ}$	

Data collection

Rigaku R-AXIS RAPID IP areadetector diffractometer Absorption correction: multi-scan (ABSCOR; Higashi, 1995) $T_{\min} = 0.905, \ \tilde{T}_{\max} = 0.980$

Refinement

 $R[F^2 > 2\sigma(F^2)] = 0.055$ $wR(F^2) = 0.118$ S = 1.222220 reflections

4032 measured reflections 2220 independent reflections 2009 reflections with $I > 2\sigma(I)$ $R_{\rm int} = 0.028$

111 parameters H-atom parameters constrained $\Delta \rho_{\rm max} = 0.40 \ {\rm e} \ {\rm \AA}^{-3}$ $\Delta \rho_{\rm min} = -0.22$ e Å⁻³

Data collection: RAPID-AUTO (Rigaku, 2001); cell refinement: RAPID-AUTO; data reduction: RAPID-AUTO; program(s) used to solve structure: SHELXS97 (Sheldrick, 2008); program(s) used to refine structure: SHELXL97 (Sheldrick, 2008); molecular graphics: SHELXTL (Sheldrick, 2008); software used to prepare material for publication: SHELXL97.

This work was supported by the National Science Foundation of China (NSFC, Nos. 50673094 and 20774102).

Supplementary data and figures for this paper are available from the IUCr electronic archives (Reference: GK2260).

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supporting information

Acta Cryst. (2010). E66, o970 [doi:10.1107/S1600536810010913]

1,4-Bis(dimethylsilyl)-2,5-diphenylbenzene

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S1. Comment

As part of our ongoing investigation on the effect of silyl substituents on the photophysics of *p*-terphenyls, we present the title compound bearing silyl substituents at the central phenyl ring (2,5-positions). Though analogues of the title compound were reported elsewhere (Feng *et al.*, 2007), their structures were not fully studied. The molecular structure of the title compound is shown in Fig.1. It is centrosymmetric, the centroid of the central benzene ring is located on an inversion center at 0,1,0. The dihedral angle between the benzene ring and phenyl substituents is 67.7 (2)°. The crystal packing is mainly stabilized by van der Waals forces.

S2. Experimental

A solution of 2,5-dibromo-1,4-diphenylbenzene (120 mg, 0.31 mmol) in anhydrous THF (10 ml) was added dropwise to a hexane solution of n-BuLi (2.5 M, 0.44 ml, 1.08 mmol) dropwise at -78 °C. The reaction mixture was stirred for 1 h and dimethylchlorosilane (118 mg, 1.24 mmol) was added via syringe at the same temperature and the mixture was allowed to warm to room temperature and stirred overnight. After being quenched with saturated NaHCO₃ solution, the mixture was extracted with Et_2O . The organic layer was washed with brine, dried over anhydrous MgSO₄, filtered, and concentrated under reduced pressure. The mixture was passed through a silica gel column with hexane as an eluent, followed by further purification by recrystallization from ethanol to give 98 mg of the white product in 91% yield.

S3. Refinement

All H-atoms were located in electron-density difference maps. Carbon-bound H atoms were placed geometrically in idealized positions and refined using a riding model with C—H (methyl) 0.98, C—H (aromatic) 0.95 Å and with $U_{iso}(H) = 1.2U_{eq}(C)$. Located in the electron-density difference map H atom from the silyl group was refined using riding model with $U_{iso}(H) = 1.2U_{eq}(Si)$.



Figure 1

The structure of the title compound showing 50% probability displacement ellipsoids and the atom-numbering scheme. The unlabelled atoms can be generated by the symmetry operation -x, -y+2, -z.

1,4-Bis(dimethylsilyl)-2,5-diphenylbenzene

Crystal data

C₂₂H₂₆Si₂ $M_r = 346.61$ Monoclinic, C2/c Hall symbol: -C 2yc a = 14.8966 (3) Å b = 6.0132 (1) Å c = 26.1211 (6) Å $\beta = 123.166$ (1)° V = 1958.64 (7) Å³ Z = 4

Data collection

Rigaku R-AXIS RAPID IP area-detector diffractometer Radiation source: rotating anode Graphite monochromator ω scans at fixed $\chi = 45^{\circ}$ Absorption correction: multi-scan (*ABSCOR*; Higashi, 1995) $T_{\min} = 0.905, T_{\max} = 0.980$ F(000) = 744 $D_x = 1.175 \text{ Mg m}^{-3}$ Mo K\alpha radiation, $\lambda = 0.71073 \text{ Å}$ Cell parameters from 4032 reflections $\theta = 2.7-27.5^{\circ}$ $\mu = 0.18 \text{ mm}^{-1}$ T = 173 KPlate, colorless $0.56 \times 0.39 \times 0.11 \text{ mm}$

4032 measured reflections 2220 independent reflections 2009 reflections with $I > 2\sigma(I)$ $R_{int} = 0.028$ $\theta_{max} = 27.5^{\circ}, \theta_{min} = 2.7^{\circ}$ $h = -19 \rightarrow 19$ $k = -7 \rightarrow 7$ $l = -33 \rightarrow 33$ Refinement

Refinement on F^2	Secondary atom site location: difference Fourier
Least-squares matrix: full	map
$R[F^2 > 2\sigma(F^2)] = 0.055$	Hydrogen site location: inferred from
$wR(F^2) = 0.118$	neighbouring sites
S = 1.22	H-atom parameters constrained
2220 reflections	$w = 1/[\sigma^2(F_o^2) + (0.0432P)^2 + 2.0232P]$
111 parameters	where $P = (F_o^2 + 2F_c^2)/3$
0 restraints	$(\Delta/\sigma)_{ m max} < 0.001$
Primary atom site location: structure-invariant	$\Delta ho_{ m max} = 0.40 \ { m e} \ { m \AA}^{-3}$
direct methods	$\Delta \rho_{\min} = -0.22 \text{ e} \text{ Å}^{-3}$

Special details

Geometry. All esds (except the esd in the dihedral angle between two l.s. planes) are estimated using the full covariance matrix. The cell esds are taken into account individually in the estimation of esds in distances, angles and torsion angles; correlations between esds in cell parameters are only used when they are defined by crystal symmetry. An approximate (isotropic) treatment of cell esds is used for estimating esds involving l.s. planes.

Refinement. Refinement of F^2 against ALL reflections. The weighted *R*-factor wR and goodness of fit *S* are based on F^2 , conventional *R*-factors *R* are based on *F*, with *F* set to zero for negative F^2 . The threshold expression of $F^2 > 2\sigma(F^2)$ is used only for calculating *R*-factors(gt) etc. and is not relevant to the choice of reflections for refinement. *R*-factors based on F^2 are statistically about twice as large as those based on *F*, and *R*-factors based on ALL data will be even larger.

Fractional atomic coordinates and isotropic or equivalent isotropic displacement parameters (\hat{A}^2)

	x	У	Ζ	$U_{ m iso}$ */ $U_{ m eq}$
Si1	-0.03046 (4)	0.64331 (9)	0.08538 (2)	0.02208 (16)
H1	0.0590	0.5194	0.1223	0.026*
C1	-0.00698 (14)	0.8349 (3)	0.03690 (8)	0.0207 (4)
C2	-0.09110 (15)	0.8753 (3)	-0.02358 (8)	0.0220 (4)
H2	-0.1545	0.7887	-0.0403	0.026*
C3	0.08631 (14)	0.9637 (3)	0.06040 (8)	0.0202 (4)
C4	0.18299 (14)	0.9316 (3)	0.12353 (8)	0.0208 (4)
C5	0.21644 (16)	1.0962 (3)	0.16753 (9)	0.0276 (4)
Н5	0.1762	1.2298	0.1578	0.033*
C6	0.30788 (17)	1.0685 (4)	0.22563 (9)	0.0314 (5)
H6	0.3292	1.1819	0.2555	0.038*
C7	0.36813 (15)	0.8762 (4)	0.24023 (8)	0.0285 (4)
H7	0.4314	0.8582	0.2798	0.034*
C8	0.33562 (16)	0.7103 (4)	0.19677 (9)	0.0310 (5)
H8	0.3763	0.5773	0.2067	0.037*
C9	0.24395 (16)	0.7377 (3)	0.13896 (8)	0.0261 (4)
Н9	0.2223	0.6231	0.1094	0.031*
C10	-0.0605 (2)	0.8174 (4)	0.13337 (10)	0.0375 (5)
H10A	-0.1249	0.9065	0.1068	0.056*
H10B	0.0002	0.9164	0.1592	0.056*
H10C	-0.0726	0.7209	0.1593	0.056*
C11	-0.14236 (19)	0.4490 (4)	0.03752 (10)	0.0377 (5)
H11A	-0.1565	0.3595	0.0637	0.057*
H11B	-0.1230	0.3509	0.0151	0.057*
H11C	-0.2068	0.5338	0.0084	0.057*

	U^{11}	U^{22}	U^{33}	U^{12}	U^{13}	U^{23}
Si1	0.0233 (3)	0.0233 (3)	0.0197 (3)	0.0028 (2)	0.0118 (2)	0.0051 (2)
C1	0.0221 (9)	0.0217 (9)	0.0194 (8)	0.0021 (7)	0.0120 (7)	0.0018 (7)
C2	0.0213 (9)	0.0241 (9)	0.0199 (8)	-0.0012 (7)	0.0110 (7)	-0.0005 (7)
C3	0.0208 (9)	0.0228 (9)	0.0162 (8)	0.0024 (7)	0.0096 (7)	0.0009 (7)
C4	0.0190 (8)	0.0251 (9)	0.0170 (8)	0.0005 (7)	0.0090 (7)	0.0016 (7)
C5	0.0268 (10)	0.0246 (10)	0.0242 (9)	0.0041 (8)	0.0094 (8)	-0.0009 (8)
C6	0.0315 (11)	0.0333 (11)	0.0202 (9)	0.0000 (9)	0.0082 (8)	-0.0051 (8)
C7	0.0202 (9)	0.0406 (12)	0.0174 (8)	0.0028 (8)	0.0056 (7)	0.0015 (8)
C8	0.0259 (10)	0.0365 (11)	0.0242 (9)	0.0115 (9)	0.0096 (8)	0.0038 (9)
C9	0.0276 (10)	0.0274 (10)	0.0199 (9)	0.0051 (8)	0.0108 (8)	-0.0020 (8)
C10	0.0482 (13)	0.0381 (12)	0.0341 (11)	0.0045 (10)	0.0275 (11)	0.0008 (10)
C11	0.0454 (13)	0.0356 (12)	0.0367 (12)	-0.0103(10)	0.0254 (11)	-0.0035 (10)

Atomic displacement parameters $(Å^2)$

Geometric parameters (Å, °)

Sil—Cl1	1.851 (2)	C6—C7	1.383 (3)
Si1—C10	1.866 (2)	С6—Н6	0.9500
Si1—C1	1.8812 (19)	C7—C8	1.385 (3)
Si1—H1	1.3623	С7—Н7	0.9500
C1—C2	1.400 (2)	C8—C9	1.384 (3)
C1—C3	1.405 (3)	С8—Н8	0.9500
C2-C3 ⁱ	1.394 (3)	С9—Н9	0.9500
С2—Н2	0.9500	C10—H10A	0.9800
C3—C2 ⁱ	1.394 (3)	C10—H10B	0.9800
C3—C4	1.494 (2)	C10—H10C	0.9800
C4—C5	1.386 (3)	C11—H11A	0.9800
C4—C9	1.395 (3)	C11—H11B	0.9800
C5—C6	1.387 (3)	C11—H11C	0.9800
С5—Н5	0.9500		
C11—Si1—C10	110.47 (11)	С5—С6—Н6	119.9
C11—Si1—C1	111.24 (9)	C6—C7—C8	119.55 (17)
C10—Si1—C1	108.04 (10)	С6—С7—Н7	120.2
C11—Si1—H1	107.7	С8—С7—Н7	120.2
C10—Si1—H1	109.4	C9—C8—C7	120.16 (19)
C1—Si1—H1	110.0	С9—С8—Н8	119.9
C2—C1—C3	117.29 (16)	С7—С8—Н8	119.9
C2—C1—Si1	118.99 (14)	C8—C9—C4	120.83 (18)
C3—C1—Si1	123.17 (13)	С8—С9—Н9	119.6
$C3^{i}$ — $C2$ — $C1$	123.17 (17)	С4—С9—Н9	119.6
C3 ⁱ —C2—H2	118.4	Si1-C10-H10A	109.5
C1—C2—H2	118.4	Si1-C10-H10B	109.5
C2 ⁱ —C3—C1	119.54 (16)	H10A—C10—H10B	109.5
C2 ⁱ —C3—C4	117.97 (16)	Si1—C10—H10C	109.5
C1—C3—C4	122.47 (16)	H10A—C10—H10C	109.5

C5—C4—C9	118.37 (16)	H10B—C10—H10C	109.5
C5—C4—C3	121.00 (17)	Si1—C11—H11A	109.5
C9—C4—C3	120.59 (17)	Si1—C11—H11B	109.5
C4—C5—C6	120.91 (18)	H11A—C11—H11B	109.5
С4—С5—Н5	119.5	Si1—C11—H11C	109.5
С6—С5—Н5	119.5	H11A—C11—H11C	109.5
C7—C6—C5	120.18 (19)	H11B—C11—H11C	109.5
С7—С6—Н6	119.9		
C11—Si1—C1—C2	23.44 (19)	C1—C3—C4—C5	-114.5 (2)
C10—Si1—C1—C2	-97.97 (17)	C2 ⁱ —C3—C4—C9	-110.8 (2)
C11—Si1—C1—C3	-165.30 (16)	C1—C3—C4—C9	67.7 (2)
C10—Si1—C1—C3	73.29 (18)	C9—C4—C5—C6	-0.4 (3)
$C3-C1-C2-C3^{i}$	-0.6 (3)	C3—C4—C5—C6	-178.25 (18)
Si1—C1—C2—C3 ⁱ	171.16 (14)	C4—C5—C6—C7	0.9 (3)
$C2-C1-C3-C2^{i}$	0.6 (3)	C5—C6—C7—C8	-1.0 (3)
Si1—C1—C3—C2 ⁱ	-170.81 (14)	C6—C7—C8—C9	0.6 (3)
C2—C1—C3—C4	-177.92 (17)	C7—C8—C9—C4	0.0 (3)
Si1—C1—C3—C4	10.7 (3)	C5—C4—C9—C8	0.0 (3)
C2 ⁱ —C3—C4—C5	67.0 (2)	C3—C4—C9—C8	177.82 (19)

Symmetry code: (i) -x, -y+2, -z.